





REPLACEMENT SHEET
APPLN. FILING DATE: DECEMBER 29, 2000
TITLE: LOW CONTAMINATION PLASMA CHAMBER
COMPONENTS AND METHODS FOR MAKING THE SAME
INVENTOR(S): CHRISTOPHER C. CHANG ET AL.
APPLN. SERIAL NO.: 09/749,917 SHEET 2 OF 4

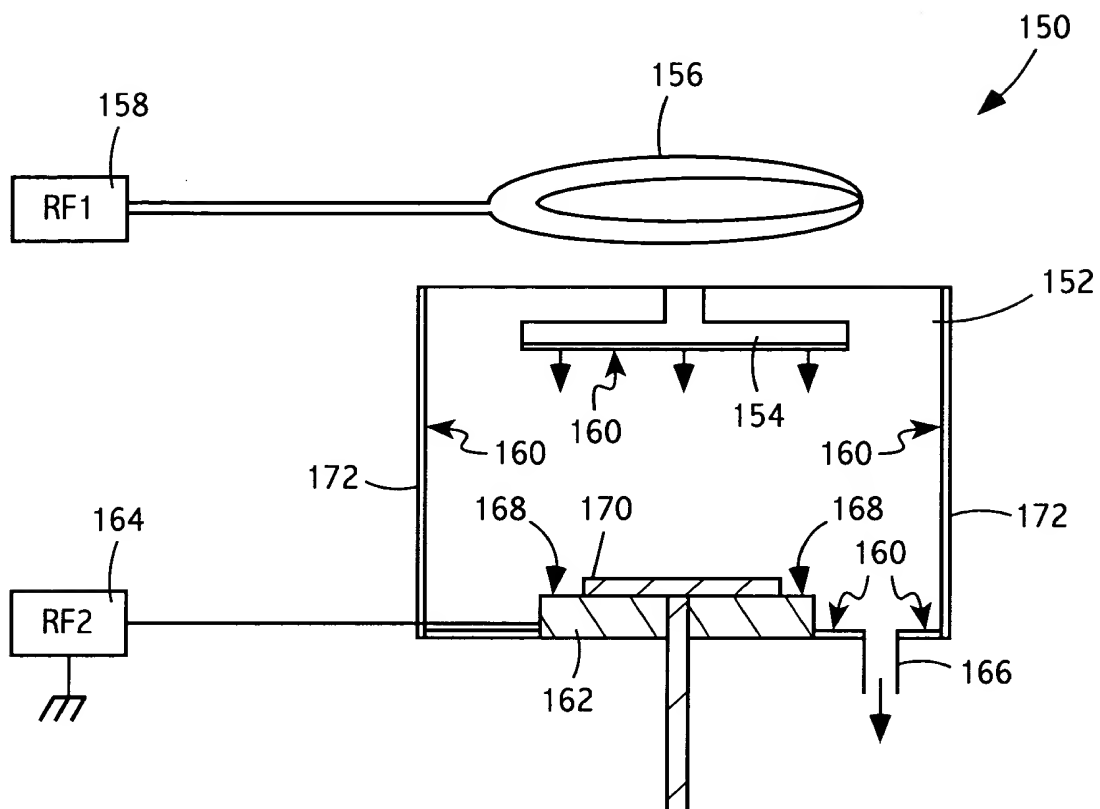


FIG. 2



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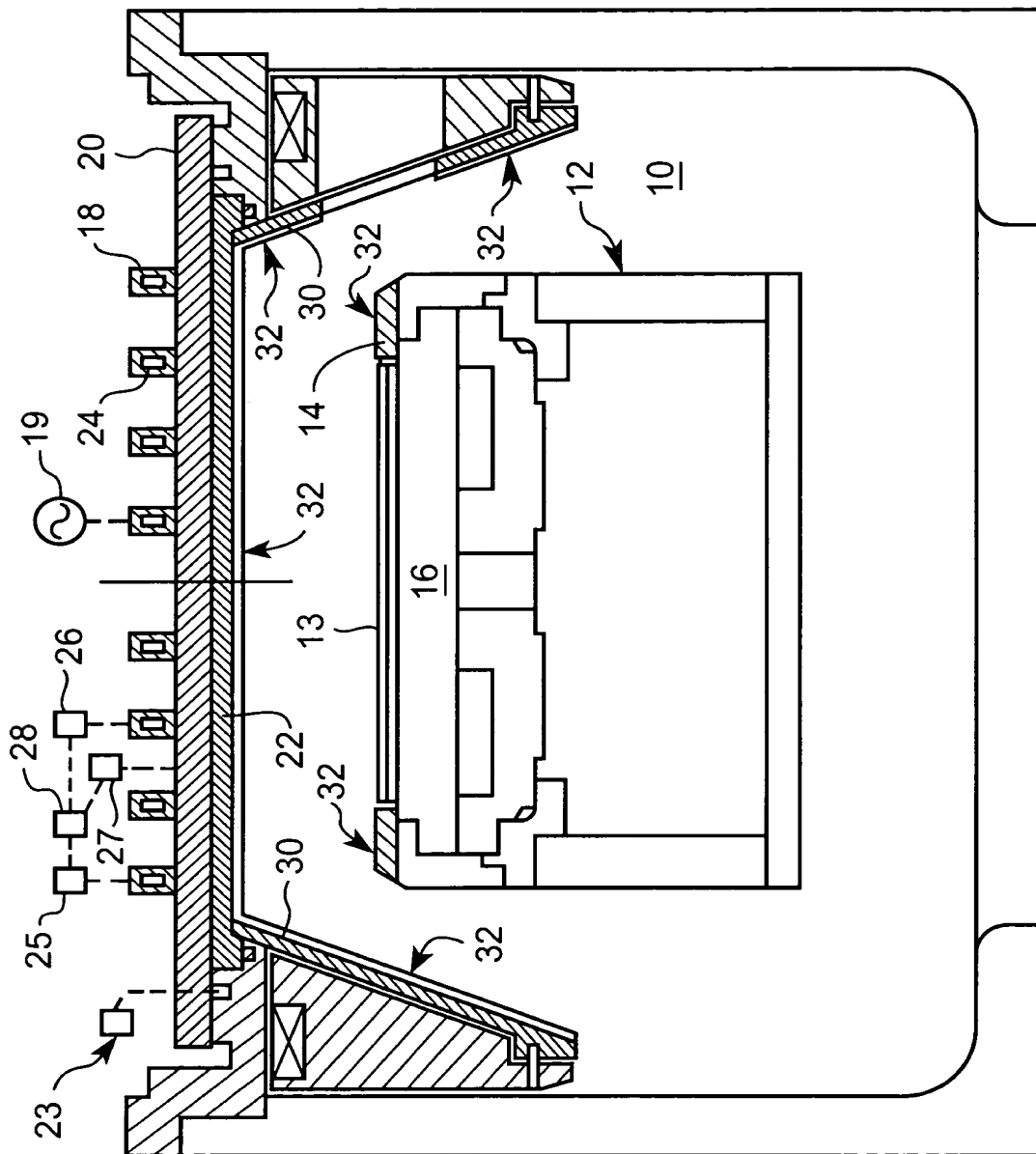


FIG. 3



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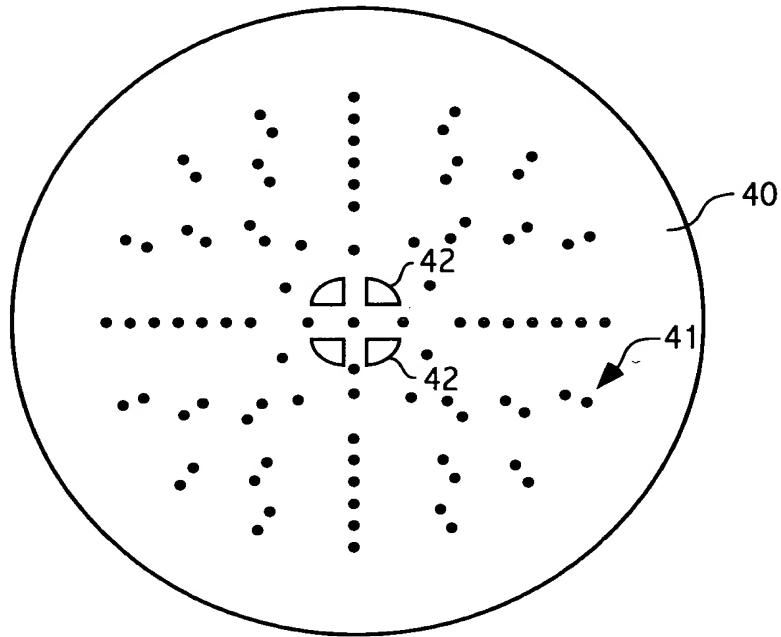


FIG. 4